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ABSTRACT

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Table of Contents

List of Figures	iii
List of Tables	iv
1 Introduction	1
1.1 Background and Beginnings	1

List of Figures

List of Tables

Chapter 1

Introduction

1.1 Background and Beginnings

Contents here, test the citation command [1]. We use the following TMDs MOS₂ [2]

Bibliography

- [1] Yuan Huang, Eli Sutter, Norman N. Shi, Jiabao Zheng, Tianzhong Yang, Dirk Englund, Hong-Jun Gao, and Peter Sutter. Reliable Exfoliation of Large-Area High-Quality Flakes of Graphene and Other Two-Dimensional Materials. *ACS Nano*, 0(0):null, 0. PMID: 26336975.
- [2] Dieter K. Schroder. *Semiconductor Material and Device Characterization*. John Wiley and Sons, Inc., Hoboken, New Jersey, 3rd edition, 2006.